TABLE 3 TO SUBPART VVVVVV OF PART 63—EMISSION LIMITS AND COMPLIANCE REQUIREMENTS FOR CONTINUOUS PROCESS VENTS

As required in §63.11496, you must comply with the requirements for continuous process vents as shown in the following table.

<table>
<thead>
<tr>
<th>For</th>
<th>You must * * *</th>
<th>Except * * *</th>
</tr>
</thead>
</table>
| 1. Each continuous process vent with a TRE \(\leq 1\). | a. Reduce emissions of total organic HAP by \(\geq 95\) percent by weight (\(\geq 85\) percent by weight for periods of start-up or shutdown) or to \(\leq 20\) ppmv by routing emissions through a closed vent system to any combination of control devices (except a flare) in accordance with the requirements of §63.982(c)(2) and the requirements referenced therein; or | i. Compliance may be based on either total organic HAP or TOC; and  
   ii. As specified in §63.11496(g). |
|                              | b. Reduce emissions of total organic by HAP by routing all emissions through a closed-vent system to a flare (except that a flare may not be used to control halogenated vent streams) in accordance with the requirements of §63.982(b) and the requirements referenced therein; or | i. Not applicable. |
|                              | c. Comply with the alternative standard specified in §63.2505 and the requirements referenced therein. | i. As specified in §63.11496(e). |
| 2. Halogenated vent stream that is controlled through combustion. | a. Comply with the requirements for halogen scrubbers in §63.11496(d). | |

TABLE 4 TO SUBPART VVVVVV OF PART 63—EMISSION LIMITS AND COMPLIANCE REQUIREMENTS FOR METAL HAP PROCESS VENTS

As required in §63.11496(f), you must comply with the requirements for metal HAP process vents as shown in the following table.

<table>
<thead>
<tr>
<th>For * * *</th>
<th>You must * * *</th>
<th>Except * * *</th>
</tr>
</thead>
<tbody>
<tr>
<td>Each CMPU with total metal HAP emissions (\geq 400) lb/yr.</td>
<td>Reduce collective uncontrolled emissions of total metal HAP emissions by (\geq 95) percent by weight by routing emissions from a sufficient number of the metal process vents through a closed-vent system to any combination of control devices, according to the requirements of §63.11496(f)(3), (4), or (5).</td>
<td>Not applicable.</td>
</tr>
</tbody>
</table>

TABLE 5 TO SUBPART VVVVVV OF PART 63—EMISSION LIMITS AND COMPLIANCE REQUIREMENTS FOR STORAGE TANKS

As required in §63.11497, you must comply with the requirements for storage tanks as shown in the following table.

<table>
<thead>
<tr>
<th>For each * * *</th>
<th>You must * * *</th>
<th>Except * * *</th>
</tr>
</thead>
<tbody>
<tr>
<td>1. Storage tank with a design capacity (\geq 40,000) gallons, storing liquid that contains organic HAP listed in Table 1 to this subpart, and for which the maximum true vapor pressure (MTVP) of total organic HAP at the storage temperature is (\geq 5.2) kPa and (&lt;76.6) kPa.</td>
<td>a. Comply with the requirements of subpart WW of this part;</td>
<td>i. All required seals must be installed by the compliance date in §63.11494.</td>
</tr>
</tbody>
</table>
For each * * *

You must * * *

Except * * *

b. Reduce total organic HAP emissions by ≥95 percent by weight by operating and maintaining a closed-vent system and control device (other than a flare) in accordance with § 63.982(c)(1); or

i. Compliance may be based on either total organic HAP or TOC;

ii. Comply with the management practice inspection requirements in § 63.11495 for the closed-vent system;

iii. When the term storage vessel is used in subpart SS of this part, the term storage tank, surge control vessel, or bottoms receiver, as defined in § 63.11502 of this subpart, applies; and

iv. The requirements do not apply during periods of planned routine maintenance of the control device, as specified in § 63.11497(b).

c. Reduce total HAP emissions by operating and maintaining a closed-vent system and a flare in accordance with § 63.982(b); or

i. The requirements do not apply during periods of planned routine maintenance of the flare, as specified in § 63.11497(b); and

ii. When the term storage vessel is used in subpart SS of this part, it means storage tank, surge control vessel, or bottoms receiver, as defined in § 63.11502 of this subpart.

iii. Not applicable.

d. Vapor balance in accordance with § 63.2470(e); or

e. Route emissions to a fuel gas system or process in accordance with the requirements in § 63.982(d) and the requirements referenced therein.

i. When the term storage vessel is used in subpart SS of this part, it means storage tank, surge control vessel, or bottoms receiver, as defined in § 63.11502.

ii. The information specified above for Items 1.a., 1.b., 1.c., 1.d, and 1.e, as applicable.

2. Storage tank with a design capacity ≥20,000 gallons and <40,000 gallons, storing liquid that contains organic HAP listed in Table 1 to this subpart, and for which the MTVP of total organic HAP at the storage temperature is ≥27.6 kPa and <76.6 kPa.

3. Storage tank with a design capacity ≥20,000 gallons, storing liquid that contains organic HAP listed in Table 1 to this subpart, and for which the MTVP of total organic HAP at the storage temperature is ≥76.6 kPa.

4. Storage tank described by Item 1, 2, or 3 in this table and emitting a halogenated vent stream that is controlled with a combustion device.

a. Comply with one of the options in Item 1 of this table.

b. Reduce emissions of hydrogen halide and halogen HAP by ≥95 percent by weight, or to ≤0.45 kg/hr or to ≤20 ppmv by using a halogen reduction device after the combustion device according to the requirements in § 63.11496(d); or

b. Reduce the halogen atom mass emission rate to ≤0.45 kg/hr or to ≤20 ppmv by using a halogen reduction device before the combustion device according to the requirements in § 63.11496(d).

TABLE 6 TO SUBPART VVVVV OF PART 63—EMISSION LIMITS AND COMPLIANCE REQUIREMENTS FOR WASTEWATER SYSTEMS

As required in §63.11408, you must comply with the requirements for wastewater systems as shown in the following table.